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APPLICATION NO.	FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/628,326		07/29/2003	Stephen Roux	1857.1940000	1857.1940000 6147	
26111	7590	01/25/2005		EXAM	INER	
		R, GOLDSTEIN &	MOHAMEDULI	MOHAMEDULLA, SALEHA R		
1100 NEW YORK AVENUE, N.W. WASHINGTON, DC 20005				ART UNIT	PAPER NUMBER	
				1756		

DATE MAILED: 01/25/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Appl	ication No.	Applicant(s)					
	l l	28,326	ROUX ET AL.					
Office Action Summary	Exan	niner	Art Unit					
U-100 THE RESERVE		na R. Mohamedulla	1756					
The MAILING DATE of this comm	nunication appears o	n the cover sheet wit	th the correspondence address	s				
A SHORTENED STATUTORY PERIOR THE MAILING DATE OF THIS COMM - Extensions of time may be available under the provision after SIX (6) MONTHS from the mailing date of this of the period for reply specified above is less than this of the period for reply is specified above, the maximuman approximation of the period for Any reply received by the Office later than three more earned patent term adjustment. See 37 CFR 1.704(UNICATION. sions of 37 CFR 1.136(a). In communication. rty (30) days, a reply within th m statutory period will apply reply will, by statute, cause th ths after the mailing date of t	no event, however, may a re ne statutory minimum of thirty and will expire SIX (6) MONT ne application to become AB/	ply be timely filed (30) days will be considered timely. THS from the mailing date of this commuration ANDONED (35 U.S.C. § 133).	nication.				
Status								
1) Responsive to communication(s)	filed on 29 July 200)3 .						
2a) ☐ This action is FINAL .	2b)⊠ This action							
3)☐ Since this application is in condit	ion for allowance ex	cept for formal matte	ers, prosecution as to the mer	rits is				
closed in accordance with the pro-	actice under <i>Ex parte</i>	e <i>Quayl</i> e, 1935 C.D.	11, 453 O.G. 213.					
Disposition of Claims								
4)⊠ Claim(s) <u>1-13</u> is/are pending in the	ne application.							
	4a) Of the above claim(s) is/are withdrawn from consideration.							
5) Claim(s) is/are allowed.								
6)⊠ Claim(s) <u>1-13</u> is/are rejected.								
7) Claim(s) is/are objected to).		•					
8) Claim(s) are subject to res		on requirement.						
Application Papers								
9)☐ The specification is objected to by	the Examiner							
10)☐ The drawing(s) filed on is/a		or b) abjected to b	v the Examiner					
Applicant may not request that any o			•					
Replacement drawing sheet(s) include	-	•	` '	121/4)				
11) The oath or declaration is objecte			· -	• •				
Priority under 35 U.S.C. § 119	•							
	ina f an fanainn muiauis.		440(-) (-1) (6)	•				
12) Acknowledgment is made of a cla a) All b) Some * c) None o 1. Certified copies of the prior	f: rity documents have	been received.						
2. Certified copies of the prior	_	•	·					
3. Copies of the certified copi	•		received in this National Stag	e _.				
application from the Interna	•	` ''						
* See the attached detailed Office a	ction for a list of the (certified copies not r	eceived.					
Attachment(s)								
 Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review 	w (PTO-049)		ımmary (PTO-413) /Mail Date					
Notice of Draitsperson's Patent Drawing Reviet Information Disclosure Statement(s) (PTO-144) Paper No(s)/Mail Date			ormal Patent Application (PTO-152)	•				

DETAILED ACTION

Claims 1-13 are pending.

Claim Rejections - 35 USC § 102

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1-13 rejected under 35 U.S.C. 102(b) as being anticipated by US# 6,239,863 to 1. Catey et al.

Catey teaches a removable cover for a reticle. A removable cover for protecting a reticle used in a lithography system is described. The removable cover includes a frame and a membrane supported by the frame. The membrane is transparent to an inspection wavelength such that the reticle can be inspected with the removable cover in place. This removable cover protects the reticle when the removable cover is in place and is removable for lithographic exposure. The removable cover can further include at least one reticle fastener that applies force to the reticle thereby preventing movement of the removable cover relative to the reticle when the removable cover is in place. A plurality of fasteners are used to position and secure the removable cover and reticle. A method of performing lithography and a lithographic system are also described (Abstract; col. 2, lines 35-45). Turning to a structure of the removable cover according to the instant invention, FIG. 1A illustrates a preferred embodiment of the removable cover 100. The removable cover includes a frame 110. Frame 110 includes an opening 121 corresponding to an inspection window. The material used for the frame should be selected with several considerations in mind. The material should be compatible with standard cleaning

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agents used with lithography systems. The material should not produce out gassing of amines, or other undesirable substances harmful to the lithographic process. The material should further be resistant to mechanical degradation. Since the removable cover is used in the high vacuum environment of EUV lithography, these material characteristics should hold true in that environment. Examples of possible materials that could be used includes fiber reinforced molded polymers, Derlin (trademark) or PTFE (Teflon (trademark)) coated metals such as aluminum or titanium. Other materials may be used without departing from this invention. Such materials could be selected by one skilled in the art given this disclosure. Frame 110 further includes a filter 111. This filter allows gas flow through the frame 110 while preventing passage of particles to the reticle. Accordingly, the cover is able to breathe during pump and vent cycles. Frame 110 further includes flanges 112 and 113. These flanges can be formed integrally with the frame, as is illustrated. As shown in the figure, flanges 112 and 113 extend in a direction perpendicular to the window defined by the frame. These flanges serve to partially surround lateral edges of a reticle when the removable cover is in place on a reticle. This relationship is shown in FIG. 1B, for example, and will be discussed below in more detail. Frame 110 further includes ridges 114, 115, and 116. As can be seen in FIG. 1, a first ridge 114 is formed on the frame adjacent the first flange 112. This first ridge 114 is used as a first resting point for a reticle when the removable cover is in place on the reticle. Second and third ridges 115, 116 are formed on the frame adjacent the second flange 113. The second and third ridges are used as second and third resting points for a reticle when the removable cover is in place on the reticle. While one skilled in the art, given this disclosure, would understand that

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more or fewer ridges could be provided without departing from the invention, the preferred embodiment includes three ridges as this number is ideal for stabilizing a reticle on the removable cover. Furthermore, while the ridges 114, 115, and 116 are provided to minimize contact between the removable cover and reticle, thereby minimizing particle generation friction, a removable cover without ridges would be within the scope of the instant invention, as would be apparent to a person skilled in the relevant art given this disclosure. Finally, while the ridges 114, 115, and 116 produce a gap between the frame 110 and a reticle, the height of the ridges can be made small enough so that gas conductance through the filter 111 is higher than through the gap created by ridges 114, 115, and 116. As can further be seen in FIG. 1A, second and third ridges 115, 116 extend up the interior side of second flange 113. These second and third ridges work in conjunction with first and second fasteners 117, 118 to secure the removable cover to the reticle, as discussed more fully below. The frame 110 further includes first and second fasteners 117, 118 located in the first flange 112. These first and second fasteners are preferably bi-stable fasteners. As used herein, the phrase "bi-stable" is meant to define a fastener that has two stable conditions: fastened and unfastened. The fastener will remain in either position without additional control or force applied to the fastener. Such fasteners, for example, may be formed as rotationally actuated fasteners that each include a bistable spring serving to hold the fasteners in either a fastened or unfastened position. Such an arrangement is shown, for example, in FIG. 2, discussed more fully below. Fasteners 117, 118, when fastened, bias the reticle towards second and third ridges 115, 116. Thus, in the preferred embodiment, when the removable cover is in place on the reticle, the reticle is in

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contact with the removable cover at seven points: first, second, and third ridges 114, 115, 116 on the surface of the removable cover facing the reticle; second and third ridges 115, 116 extending on the interior side of the second flange 113, and at the first and second fasteners 117, 118. This is illustrated in FIG. 1B, which shows a removable cover 100 in place on a reticle 120 having a patterned side facing the removable cover. In this manner, the reticle is firmly secured to the removable cover thereby eliminating movement of the reticle relative to the cover. At the same time, contact between the reticle and the cover is minimized. Since the reticle 120 is used in reflective lithography systems, any particles that settle on the side of the reticle away from the cover will not contribute to degradation of the reflected image. While one skilled in the art, given this disclosure, would understand that the fasteners, or ridges, or both, could be omitted without departing from the instant invention, these elements are included in the preferred embodiment to minimize particle generation (col. 5, line 30-col. 6, line 55).

Conclusion

2. Any inquiry concerning this communication or earlier communications from the Examiner should be directed to Saleha Mohamedulla whose telephone number is (571) 272-1387. The Examiner can normally be reached Monday-Friday, from 8:00 AM to 4:30 PM.

If attempts to reach the Examiner by telephone are unsuccessful, the Examiner's supervisor, Mark Huff, can be reached on (571) 272-1385. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

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may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Saleha R. Mohamedulla

Patent Examiner

Technology Center 1700

January 24, 2005